

Notice of References Cited	Application/Control No. 10/710,843	Applicant(s)/Patent Under Reexamination LIN ET AL.	
	Examiner Jae Lee	Art Unit 2823	Page 1 of 1

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*	B	US-2004/0248334 A1	12-2004	Hoss et al.	438/039
*	C	US-2005/0218414 A1	10-2005	Ueda et al.	257/094
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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